## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:		Docket No.:	4240-104
Applicants:	JUNG, Hee Tae, et al.	Conf. No.:	9621
Application No.:	10/805,044	) Art Unit:	1639
Date Filed:	March 19, 2004	Examiner:	Christopher M. Gross
Title:	METHOD FOR FABRICATING A BIOCHIP USING THE HIGH DENSITY CARBON NANOTUBE FILM OR PATTERN	Customer No.: ) ) )	23448

## **CERTIFICATE OF EFS FILING**

I hereby certify that this document is being filed via EFS in the United States Patent and Trademark Office on January 28, 2009.

/kelly k. reynolds/

## RESPONSE TO OCTOBER 28, 2008 OFFICE ACTION IN U.S. PATENT APPLICATION NO. 10/805,044

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

This responds to the October 28, 2008 Final Office Action. The time for responding to the October 28, 2008 Final Office Action without extension was set at three months, or January 28, 2009. This Response is therefore timely.

Please amend the claims of the above-identified patent application as set out in **Section I**, **Amendments to the Claims**, beginning on page 3 hereof.

Reconsideration of the application in view of the amendments to the specification and claims, and the ensuing remarks set out in **Section II, Remarks**, beginning on page 9 hereof, is respectfully requested.

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